

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Hiroyuki MATSUURA

CONFIRMATION NO.: 8170

U.S. Serial No.: 10/563,208

Group Art Unit: 3743

Filed: January 3, 2006

Examiner: Christopher D. Pilling

For: LOW PRESSURE PROCESSING SYSTEM, LOW PRESSURE PROCESSING
METHOD, AND PRESSURE CONTROL VALVE**THIRD INFORMATION DISCLOSURE STATEMENT**

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Pursuant to the duty of disclosure under 37 C.F.R. 1.56, Applicant encloses an Information Disclosure Citation Form (PTO-1449) which lists the documents noted in the Office Action mailed on March 18, 2010 in connection with Applicant's counterpart in Taiwan. No copy of documents 1-3 listed in the Office Action are enclosed because they were cited previously by the Applicant and by the Examiner in this case. Document 4 in the Taiwan Office Action has not been cited previously. It, however, has a U.S. counterpart, namely U.S. 6,123,909. Therefore, TW 453,974 is not enclosed but U.S. 6,123,909 is enclosed.

No fees are believed due with this filing, however, if for any reason fees are required relative to this filing, the Commissioner is authorized to charge the fees to SGR Deposit Account No. 02-4300.

It is respectfully requested that the cited documents be considered by the Examiner, that they be made officially of record therein, and that the documents be listed on the face of any patent which may issue from this application.

Respectfully submitted,
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By:



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